



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 27, 2026

IGI Report Number

LG831610107

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT

Measurements

10.64 X 7.36 X 5.00 MM

GRADING RESULTS

Carat Weight

3.44 CARATS

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

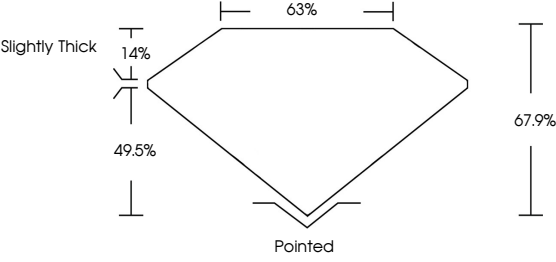
Inscription(s)

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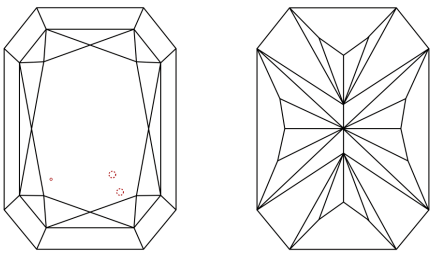
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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10.64 X 7.36 X 5.00 MM

Carat Weight

3.44 CARATS

Color Grade

D

Clarity Grade

VS 1

Depth

67.9%

Table

63%

Graile

Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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